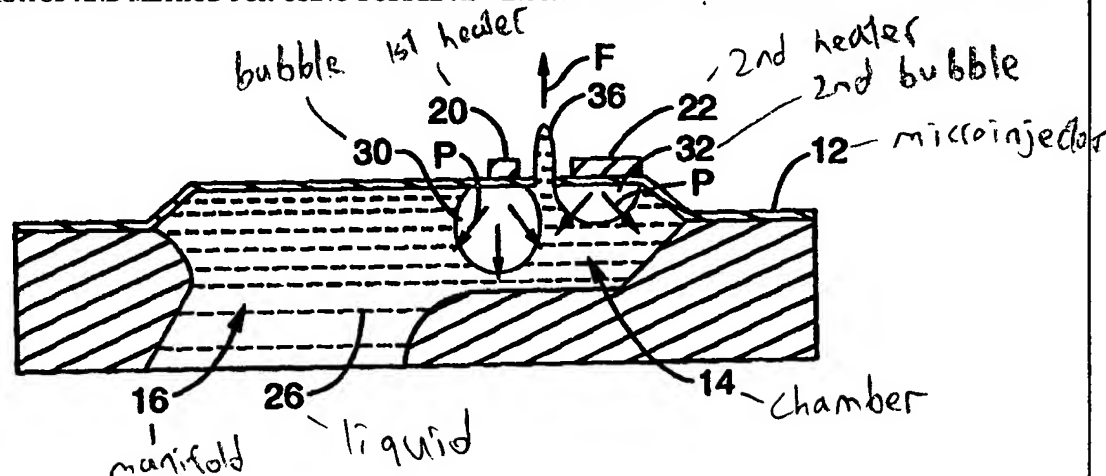




INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(51) International Patent Classification ⁶ : B41J 2/05, 2/055		A1	(11) International Publication Number: WO 99/37486
			(43) International Publication Date: 29 July 1999 (29.07.99)
(21) International Application Number: PCT/US99/01338		(81) Designated States: AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, CA, CH, CN, CU, CZ, DE, DK, EE, ES, FI, GB, GE, GH, GM, HR, HU, ID, IL, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MD, MG, MK, MN, MW, MX, NO, NZ, PL, PT, RO, RU, SD, SE, SG, SI, SK, SL, TJ, TM, TR, TT, UA, UG, UZ, VN, YU, ZW, ARIPO patent (GH, GM, KE, LS, MW, SD, SZ, UG, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, CH, CY, DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GW, ML, MR, NE, SN, TD, TG).	
(22) International Filing Date: 22 January 1999 (22.01.99)			
(30) Priority Data: 60/073,293 23 January 1998 (23.01.98) US 09/235,663 22 January 1999 (22.01.99) US			
(71)(72) Applicants and Inventors: KIM, Chang-Jin [KR/US]; 827 Levering Avenue #709, Los Angeles, CA 90024 (US). TSENG, Fan-Gang [-/US]; 12131 Culver Boulevard #3, Los Angeles, CA 90066 (US). HO, Chih-Ming [US/US]; 11959 Mayfield Avenue #9, Brentwood, CA 90049 (US).			
(74) Agent: WONG, Steve, A.; Chan Law Group LC, Suite 2288, 911 Wilshire Boulevard, Los Angeles, CA 90017 (US).		Published With international search report. Before the expiration of the time limit for amending the claims and to be republished in the event of the receipt of amendments.	

(54) Title: APPARATUS AND METHOD FOR USING BUBBLE AS VIRTUAL VALVE IN MICROINJECTOR TO EJECT FLUID



(57) Abstract

An apparatus and method for forming a bubble (30) within a microchannel of a microinjector (12) to function as a valve mechanism between the chamber (14) and manifold (16), that provides for a high resistance to liquid exiting the chamber through the manifold during fluid ejection through an orifice (18) and that also provides a low resistance to refilling of liquid into the chamber after ejection of fluid and collapse of the bubble. This effectively minimizes cross talk between adjacent chambers and increases injection frequency of the microinjector. The formation of a second bubble (32) within the chamber (14) coalesces with a first formed bubble (30) between the chamber (14) and manifold (16) to abruptly terminate the ejection of fluid, thereby eliminating satellite droplets.

Fig. 2A
p. 8, lines 6-8
p. 9, lines 11-12

FOR THE PURPOSES OF INFORMATION ONLY

Codes used to identify States party to the PCT on the front pages of pamphlets publishing international applications under the PCT.

AL	Albania	ES	Spain	LS	Lesotho	SI	Slovenia
AM	Armenia	FI	Finland	LT	Lithuania	SK	Slovakia
AT	Austria	FR	France	LU	Luxembourg	SN	Senegal
AU	Australia	GA	Gabon	LV	Latvia	SZ	Swaziland
AZ	Azerbaijan	GB	United Kingdom	MC	Monaco	TD	Chad
BA	Bosnia and Herzegovina	GE	Georgia	MD	Republic of Moldova	TG	Togo
BB	Barbados	GH	Ghana	MG	Madagascar	TJ	Tajikistan
BE	Belgium	GN	Guinea	MK	The former Yugoslav Republic of Macedonia	TM	Turkmenistan
BF	Burkina Faso	GR	Greece	ML	Mali	TR	Turkey
BG	Bulgaria	HU	Hungary	MN	Mongolia	TT	Trinidad and Tobago
BJ	Benin	IE	Ireland	MR	Mauritania	UA	Ukraine
BR	Brazil	IL	Israel	MW	Malawi	UG	Uganda
BY	Belarus	IS	Iceland	MX	Mexico	US	United States of America
CA	Canada	IT	Italy	NE	Niger	UZ	Uzbekistan
CF	Central African Republic	JP	Japan	NL	Netherlands	VN	Viet Nam
CG	Congo	KE	Kenya	NO	Norway	YU	Yugoslavia
CH	Switzerland	KG	Kyrgyzstan	NZ	New Zealand	ZW	Zimbabwe
CI	Côte d'Ivoire	KP	Democratic People's Republic of Korea	PL	Poland		
CM	Cameroon	KR	Republic of Korea	PT	Portugal		
CN	China	KZ	Kazakhstan	RO	Romania		
CU	Cuba	LC	Saint Lucia	RU	Russian Federation		
CZ	Czech Republic	LJ	Liechtenstein	SD	Sudan		
DE	Germany	LK	Sri Lanka	SE	Sweden		
DK	Denmark	LR	Liberia	SG	Singapore		
EE	Estonia						

TITLE OF THE INVENTION
APPARATUS AND METHOD FOR USING BUBBLE AS VIRTUAL VALVE IN
MICROINJECTOR TO EJECT FLUID

CROSS-REFERENCE TO RELATED APPLICATIONS

This application claims priority from U.S. provisional application serial number
60/073,293 filed on January 23, 1998.

STATEMENT REGARDING FEDERALLY SPONSORED RESEARCH
OR DEVELOPMENT

Not Applicable

REFERENCE TO A MICROFICHE APPENDIX

Not Applicable

BACKGROUND OF THE INVENTION

1. Field of the Invention

This invention pertains generally to liquid injectors, and more particularly to an apparatus and method for ejecting liquid from a microdevice.

2. Description of the Background Art

Liquid droplet injectors are widely used for printing in inkjet printers. Liquid droplet injectors, however, can also be used in a multitude of other potential applications, such as fuel

injection systems, cell sorting, drug delivery systems, direct print lithography, and micro jet propulsion systems, to name a few. Common to all these applications, a reliable and low-cost liquid droplet injector which can supply high quality droplets with high frequency and high spatial resolution, is highly desirable.

Only several devices have the ability to eject liquid droplets individually and with uniform droplet size. Among the liquid droplet injection systems presently known and used, injection by a thermally driven bubble has been most successful of such devices due to its simplicity and relatively low cost.

Thermally driven bubble systems, which are also known as bubble jet systems, suffer from cross talk and satellite droplets. The bubble jet system uses a current pulse to heat an electrode to boil liquid in a chamber. As the liquid boils, a bubble forms in the liquid and expands, functioning as a pump to eject a column of liquid from the chamber through an orifice, which forms into droplets. When the current pulse is terminated, the bubble collapses and liquid refills the chamber by capillary force. The performance of such a system can be measured by the ejection speed and direction, size of droplets, maximum ejection frequency, cross talk between adjacent chambers, overshoots and meniscus oscillation during liquid refilling, and the emergence of satellite droplets. During printing, satellite droplets degrade image sharpness, and in precise liquid control, they reduce the accuracy of flow estimation. Cross talk occurs when bubble jet injectors are placed in arrays with close pitch, and droplets eject from adjacent nozzles.

Most thermal bubble jet systems place a heater at the bottom of the chamber, which loses significant energy to the substrate material. Additionally, bonding is typically used to

attach the nozzle plate to its heater plate, which limits nozzle spatial resolution due to the assembly tolerance required. Moreover, the bonding procedure may not be compatible with IC precess, which could be important if the integration of microinjector array with controlling circuit is desired to reduce wiring and to ensure compact packaging.

To solve cross talk and overshoot problems, it has typically been the practice to increase the channel length or adding chamber neck to increase fluid impedance between the chamber and reservoir. However, these practices slow the refilling of liquid into the chamber and greatly reduce the maximum injection frequency of the device.

The most troublesome problem with existing inkjet systems is satellite droplet because it causes image blurring. The satellite droplets that trail the main droplet hit the paper surface at slightly different locations than the main one as the printhead and paper are in relative motion. There is no known effective means or method to solve the satellite droplet problem that is readily available and economical.

Accordingly, there is a need for a liquid droplet injection system that minimizes cross talk without slowing down the liquid refilling rate, thereby maintaining a high frequency response while eliminating satellite droplets, all without adding complexity to the design and manufacturing. The present invention satisfies these needs, as well as others, and generally overcomes the deficiencies found in the background art.

BRIEF SUMMARY OF THE INVENTION

The present invention pertains to an apparatus and method for forming a bubble within a chamber of a microinjector to function as a valve mechanism between the chamber

and manifold, thereby providing high resistance to liquid exiting the chamber to the manifold during fluid ejection through the orifice and also providing a low resistance to refilling of liquid into the chamber after ejection of fluid and collapse of the bubble.

In general terms, the apparatus of the present invention generally comprises a microinjector having a chamber and a manifold in flow communication therethrough, an orifice in fluid communication with the chamber, at least one means for forming a bubble between the chamber and manifold and a means to pressurize the chamber

When the bubble is formed at the entrance of the chamber, the flow of liquid out the chamber to the manifold is restricted. The pressurization means, which pressurizes the chamber after formation of the bubble, increases chamber pressure such that fluid is forced out the orifice. After ejection of fluid through the orifice, the bubble collapses and allows liquid to rapidly refill the chamber.

As the chamber is pressurized while the bubble is blocking the chamber from the manifold and adjacent chambers, the cross talk problem is minimized as well.

In the preferred embodiment of the invention, the means for forming the bubble comprises a first heater disposed adjacent the chamber. The pressurization means comprises a second heater capable of forming a second bubble within the chamber. The heaters are disposed adjacent the orifice and comprise an electrode connected in series and having differing resistances due to variations in electrode width. The first heater has a narrower electrode than the second heater, thereby causing the first bubble to form before the second bubble, even when a common electrical signal is applied therethrough.

As the first and second bubble expand, they approach each other and ultimately

coalesce, thereby distinctly cutting off the flow of liquid through the orifice and resulting in elimination or significant reduction of satellite droplets.

An object of the present invention is to provide a microinjector apparatus that eliminates satellite droplets.

Another object of the present invention is to provide a microinjector apparatus that minimizes cross talk.

Still another object of the present invention is to provide a microinjector apparatus that allows for the rapid refill of liquid into the chamber after fluid ejection.

Still another object of the present invention is to provide a method for ejecting liquid from a microinjector chamber that minimizes satellite droplets.

Still another object of the present invention is to provide a method for ejecting fluid from a microinjector chamber that minimizes cross talk.

Still another object of the present invention is to provide a method for ejecting fluid from a microinjector chamber that allows for the rapid refill of liquid into the chamber after fluid ejection.

Further objects and advantages of the invention will be brought out in the following portions of the specification, wherein the detailed description is for the purpose of fully disclosing preferred embodiments of the invention without placing limitations thereon.

BRIEF DESCRIPTION OF THE DRAWINGS

The invention will be more fully understood by reference to the following drawings which are for illustrative purposes only:

FIG. 1 is a perspective view of a section of a microinjector array apparatus in accordance with the present invention.

FIG. 2A is a cross-sectional view of a chamber and manifold of the microinjector array apparatus shown in FIG. 1

FIG. 2B is a cross-sectional view of a chamber and manifold shown in FIG. 2A illustrating the formation of a first bubble followed by a second bubble to eject fluid out of an orifice.

FIG. 2C is a cross-sectional view of a chamber and manifold shown in FIG. 2A illustrating the coalescence of a first and second bubble to terminate ejection of liquid from an orifice.

FIG. 2D is a cross-sectional view of a chamber and manifold shown in FIG. 2A illustrating a collapse of a first bubble followed by a second bubble to allow fluid to refill into the chamber.

FIG. 3 is a top plan view of a silicon wafer used to fabricate a microinjector array apparatus of the present invention.

FIG. 4 is a cross-sectional view of a silicon wafer shown in FIG. 3 taken along line 4-4.

FIG. 5 is a top plan view of a silicon wafer shown in FIG. 3 etched from its backside to form a manifold.

FIG. 6 is a cross-sectional view of a silicon wafer shown in FIG. 5 taken along line 6-6.

FIG. 7 is a top plan view of a silicon wafer shown in FIG. 5 etched to enlarge the depth of a chamber .

FIG. 8 is a cross-sectional view of a silicon wafer shown in FIG. 7 taken along line 8-8.

FIG. 9 is a top plan view of a silicon wafer shown in FIG. 7 with heaters deposited and patterned thereon.

FIG. 10 is a cross-sectional view of a silicon wafer shown in FIG. 9 taken along line 10-10.

FIG. 11 is a top plan view of a silicon wafer shown in FIG. 9 with an orifice formed.

FIG. 12 is a cross-sectional view of a silicon wafer shown in FIG. 11 taken along line 12-12.

DETAILED DESCRIPTION OF THE INVENTION

Referring more specifically to the drawings, for illustrative purposes the present invention is embodied in the apparatus generally shown in FIG. 1 through FIG. 12. It will be appreciated that the apparatus may vary as to configuration and as to details of the parts without departing from the basic concepts as disclosed herein.

Referring first to FIG. 1, an array 10 of a microinjector apparatus 12 is generally shown. Array 10 comprises a plurality of microinjectors 12 disposed adjacent one another. Each microinjector comprises a chamber 14, a manifold 16, an orifice 18, a first heater 20 and a second heater 22. First heater 20 and second heater 22 are typically electrodes connected in series to a common electrode 24.

Referring also to FIG. 2A, chamber 14 is adapted to be filled with liquid 26. Liquid 26 can include, but is not limited to, ink, gasoline, oil, chemicals, biomedical solution, water or the like, depending on the specific application. The meniscus level 28 of liquid 26 generally stabilizes at orifice 18. Manifold 16 is adjacent to and in flow communication with chamber

14. Liquid from a reservoir (not shown) is supplied to chamber 14 by passing through manifold 16. First heater 20 and second heater 22 are situated adjacent orifice 18 and above chamber 14 to prevent heat loss to the substrate. First heater 20 is disposed adjacent manifold 16 while second heater 22 is disposed adjacent chamber 14. As can be seen in FIG. 2A, the cross-section of first heater 20 is narrower than that of second heater 22.

Referring also to FIG. 2B, since first heater 20 and second heater 22 are connected in series, a common electrical pulse can be used to activate both first heater 20 and second heater 22 simultaneously. Due to first heater 20 having a narrower cross-section there is a higher power dissipation of the current pulse, thereby causing the first heater 20 to heat up more quickly, in response to the common electrical pulse, than second heater 22, which has a wider cross-section. This allows for simplifying the design by eliminating the need for a means to sequentially activate first heater 20 and second heater 22. The activation of first heater causes a first bubble 30 to form between manifold 16 and chamber 14. As first bubble 30 expands in the direction of arrows P, first bubble 30 begins to restrict fluid flow to manifold 16, thereby forming a virtual valve that isolates chamber 14 and shielding adjacent chambers from cross talk. A second bubble 32 is formed under second heater 22 after formation of first bubble 30, and as second bubble 32 expands in the direction of arrows P, chamber 14 is pressurized causing liquid 26 to be ejected through orifice 18 as a liquid column 36 in direction F.

first and
second
heater
in series

Referring also to FIG. 2C, as first bubble 30 and second bubble 32 continue to expand, first bubble 30 and second bubble 32 approach each other and terminates ejection of liquid through orifice 18. As first heater 20 and second heater 22 begin to coalesce, the tail 34 of liquid column 36 is abruptly cut off, thereby preventing the formation of satellite droplets.

Referring also to FIG. 2D, termination of the electrical pulse causes first bubble 30 to begin collapsing in the direction shown in P. The near instantaneous collapse of first bubble 30 allows fluid 26 to rapidly refill chamber 14 in the direction shown by arrows R, as there is no more liquid restriction between manifold 16 and chamber 14.

As can be seen therefore, a method for ejecting fluid 26 from a microinjector apparatus 12 in accordance with the present invention, generally comprises the steps of:

- (a) generating first bubble 30 in fluid-filled chamber 14 of microinjector apparatus 12;
- (b) pressurizing chamber 14 to eject fluid 26 from chamber 14, wherein the pressurizing step comprises generating second bubble 32 in chamber 14;
- (c) enlarging first bubble 30 in chamber 14 to serve as a virtual valve for restricting fluid flow between chamber 14 and the manifold 16;
- (d) enlarging second bubble 32 in chamber 14, whereby first bubble 30 and second bubble 32 approach each other to abruptly terminate the ejection of fluid from chamber 14; and
- (e) collapsing first bubble 30 to hasten refill of fluid into chamber 14.

} virtual valve

Referring also to FIG. 3 and FIG. 4, combined surface and bulk micromachine technology is used to fabricate a microinjector array 10 on a silicon wafer 38 without any wafer bonding process. The manufacturing process begins by depositing and patterning phosphosilicate-glass (PSG) as chamber sacrificial layer 40 and depositing approximately a low-stress silicon nitride 42 as chamber top layer.

Silicon wafer 38 is then etched from its backside 44, as shown in FIG. 5 and FIG. 6, by

potassium hydroxide (KOH) to form manifold 16. The sacrificial PSG layer 40 is removed by hydrofluoric acid (HF). As can be seen in FIG. 7 and FIG. 8, another KOH etching enlarges depth of chamber 14 by precise time control. Extra care must be undertaken during this step because the convex corners of chamber 14 are also attacked and rounded.

Referring also to FIG. 9 and FIG. 10, first heater 20 and second heater 22 are deposited and patterned. First heater 20 and second heater 22 are preferably platinum. Metal wires 44 are formed and an oxide layer 46 is deposited on top for passivation. An interconnection 48 between first heater 20 and common electrode 24 is disposed beneath oxide layer 46. Referring finally to FIG. 11 and FIG. 12, orifice 18 is formed. assuming a lithography capability of 3 μm line width, orifice 18 may be as small as approximately 2 μm , and the pitch between orifices 18 may be as low as approximately 15 μm . It can be seen that convex corners 47 of chamber 14 become distinctly defined as a result of the etching.

Accordingly, it will be seen that this invention provides for a novel microinjector that uses a bubble to restrict fluid flow in a microchannel, thereby preventing the escape of liquid from chamber to the manifold during fluid ejection through the orifice. It will also be seen that a second bubble, in conjunction with a first bubble is used to abruptly cut off the liquid column being ejected through the orifice, thereby eliminating satellite droplets. Although the description above contains many specificities, these should not be construed as limiting the scope of the invention but as merely providing illustrations of some of the presently preferred embodiments of this invention. Thus the scope of this invention should be determined by the appended claims and their legal equivalents.

CLAIMS

What is claimed is:

1. An apparatus for using a bubble as virtual valve in a microinjector to eject fluid, comprising:
 - (a) a microchannel;
 - (b) means for generating a first bubble in said microchannel when said microchannel is filled with liquid; and
 - (c) means for pressurizing said microchannel when said microchannel is filled with liquid, to eject fluid from said microchannel.
2. An apparatus as recited in claim 1, wherein said bubble generating means comprises a first heater.
3. An apparatus as recited in claim 2, wherein said microchannel pressurizing means comprises a second heater capable of generating a second bubble.
4. An apparatus as recited in claim 3, wherein said first heater and said second heater are disposed such that said first bubble and said second bubble expand toward each other to abruptly terminate the ejection of liquid from said microchannel.
5. An apparatus as recited in claim 3, wherein said first heater and said second heater are driven by a common signal.

6. An apparatus as recited in claim 3, wherein said first heater and said second heater are connected in series.
7. An apparatus as recited in claim 1, wherein generation of said first bubble restrict flow of liquid in said microchannel by serving as a virtual valve.
8. An apparatus for using bubble as virtual valve in a microinjector to eject liquid, comprising:
 - (a) chamber;
 - (b) a manifold in flow communication with said chamber for supplying liquid to said chamber;
 - (c) an orifice in flow communication with said chamber;
 - (d) means for generating a first bubble within said chamber when said chamber is filled with liquid; and
 - (e) means for pressurizing said chamber subsequent to formation of the first bubble, wherein pressurization of said chamber causes fluid in said chamber to eject through said orifice.
9. The apparatus as recited in claim 8, wherein said first bubble generating means comprises a first heater.
10. The apparatus as recited in claim 9, wherein said chamber pressurization means

comprises a second heater capable of generating a second bubble.

11. An apparatus as recited in claim 10, wherein said first heater and said second heater are driven by a common signal.

12. An apparatus as recited in claim 10, wherein said first heater and said second heater are connected in series.

13. An apparatus as recited in claim 10, wherein said first and said second heater are disposed adjacent said orifice such that said first and said second bubble coalesce to abruptly terminate the ejection of liquid from said orifice.

14. An apparatus as recited in claim 8, wherein generation of said first bubble restricts flow of liquid out of said chamber during pressurization by serving as a virtual valve between said chamber and said manifold.

15. A method for ejecting fluid from a microchannel, comprising the steps of:

- (a) generating a first bubble in a liquid-filled microchannel; and
- (b) pressurizing said microchannel to eject fluid from said microchannel.

16. A method as recited in claim 15, wherein said pressurizing step comprises generating a second bubble in said microchannel.

17. A method as recited in claim 16, further comprising the steps of:
- (a) enlarging said first bubble in the microchannel to serve as a virtual valve for restricting liquid flow between the chamber and the manifold; and
 - (b) enlarging said second bubble in the microchannel, whereby said first bubble and said second bubble approach each other to abruptly terminate the ejection of liquid from the microchannel.
18. A method as recited in claim 17, further comprising the step of collapsing said first bubble to hasten flow of liquid into the microchannel.
19. A method as recited in claim 16, wherein a common signal is used to sequentially initiate generation of both said first bubble and said second bubble.
20. An apparatus as recited in claim 16, wherein said first heater and said second heater are connected in series.
21. A method as recited in claim 16, wherein a first heater is used to generate and enlarge said first bubble and a second heater is used to generate and enlarge said second bubble, and wherein said first heater enlarges said first bubble faster than said second heater enlarges said second bubble.
22. A method for ejecting liquid from a microinjector having a chamber, a

manifold for supplying liquid to the chamber and an orifice in flow communication with the chamber, comprising the steps of:

- (a) generating a first bubble in the chamber when the chamber is filled with liquid;
and
- (b) pressurizing the chamber to eject liquid through the orifice.

23. A method as recited in claim 22, wherein said pressurizing step comprises generating a second bubble in the chamber.

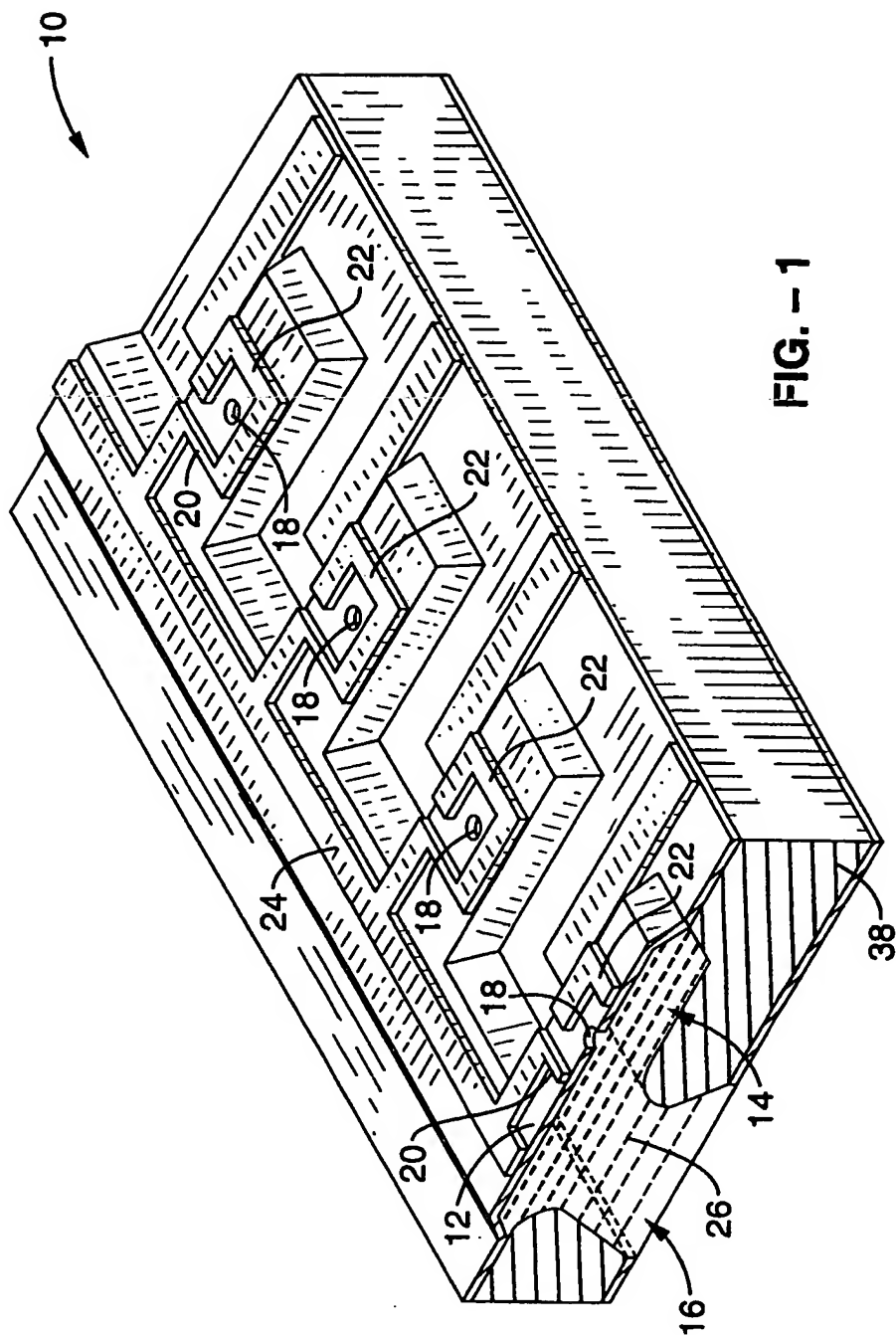
24. A method as recited in claim 23, further comprising the steps of:
- (a) enlarging said first bubble in the chamber to serve as a virtual valve for restricting liquid flow between the chamber and the manifold; and
 - (b) enlarging said second bubble in the chamber, whereby said first bubble and said second bubble coalesce to abruptly terminate the ejection of liquid from the chamber.

25. A method as recited in claim 24, further comprising the step of collapsing said first bubble to hasten flow of liquid into the chamber.

26. A method as recited in claim 23, wherein a common signal is used to sequentially initiate generation of both said first bubble and said second bubble.

27. An apparatus as recited in claim 23, wherein said first heater and said second heater are connected in series.

28. A method as recited in claim 23, wherein a first heater is used to generate and enlarge said first bubble and a second heater is used to generate and enlarge said second bubble, and wherein said first heater enlarges said first bubble faster than said second heater enlarges said second bubble.



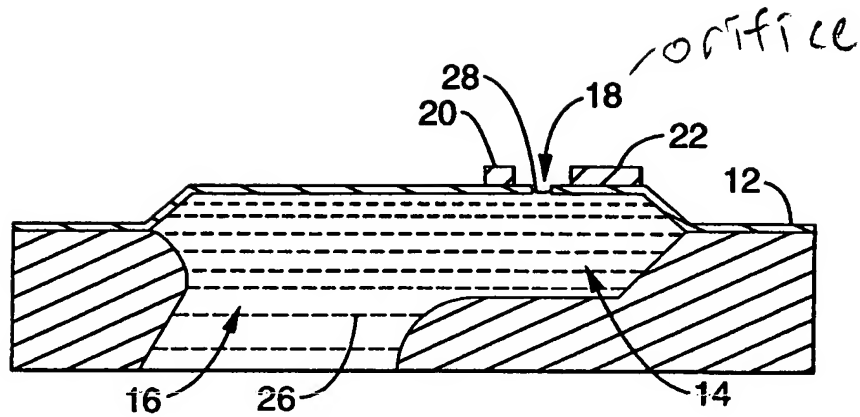


FIG. - 2A

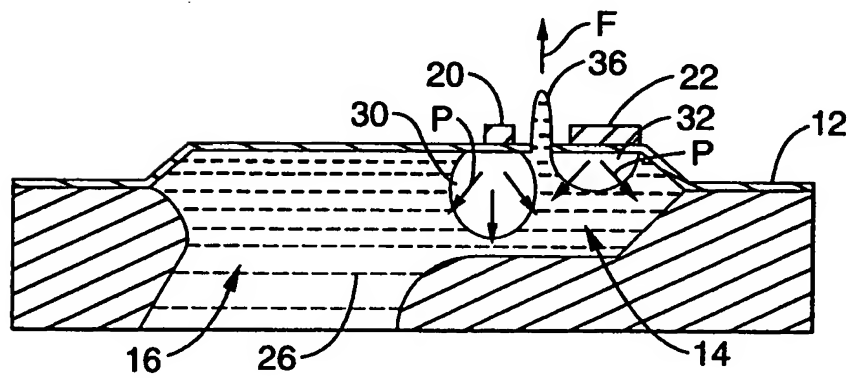


FIG. - 2B

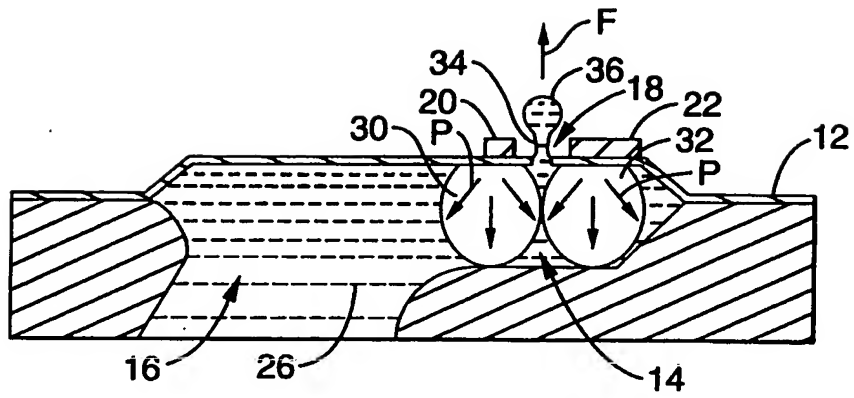


FIG. - 2C

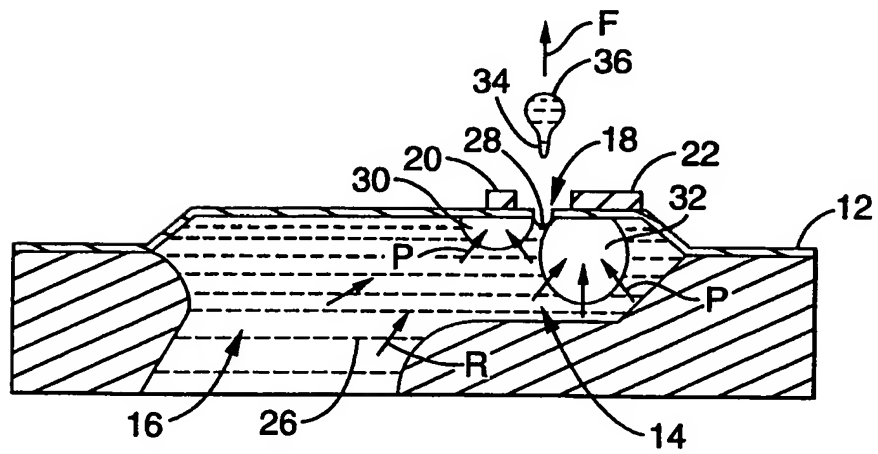


FIG. - 2D

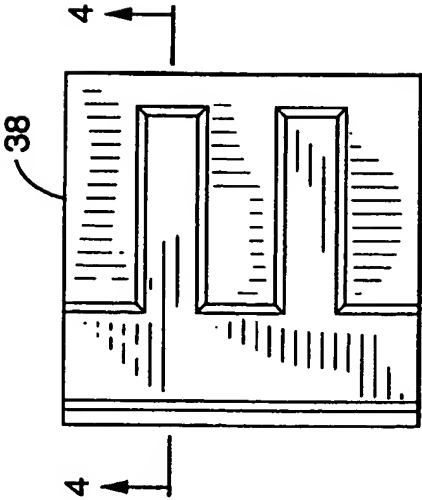


FIG. - 3

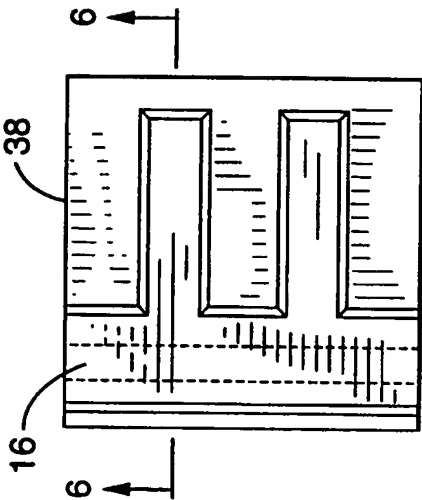


FIG. - 5

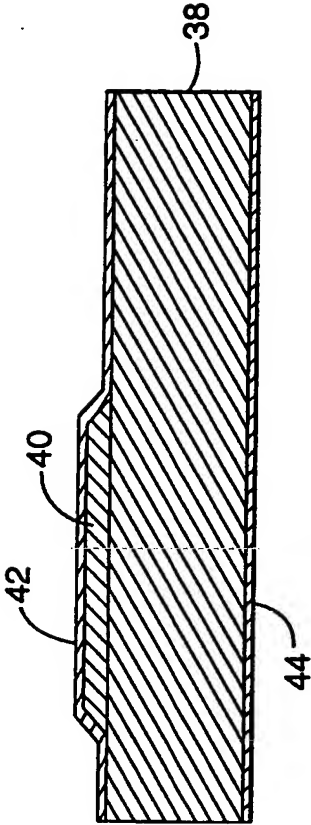


FIG. - 4

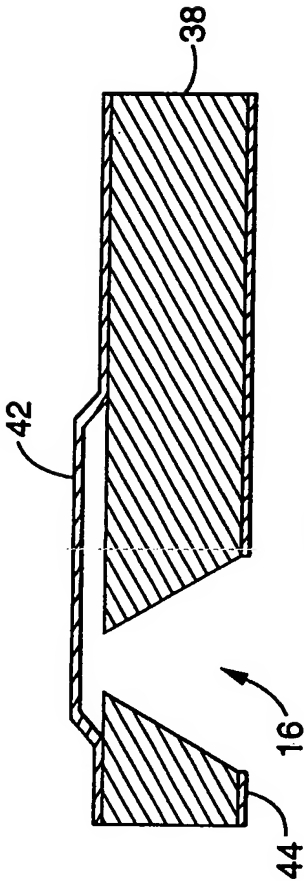


FIG. - 6

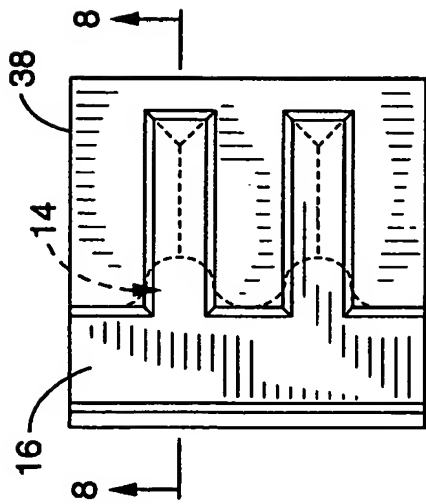


FIG. - 7

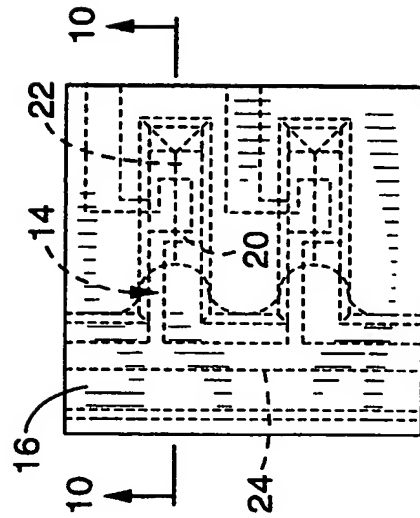


FIG. - 9

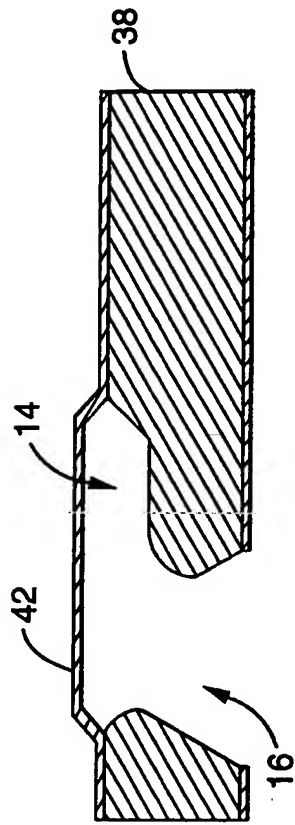


FIG. - 8

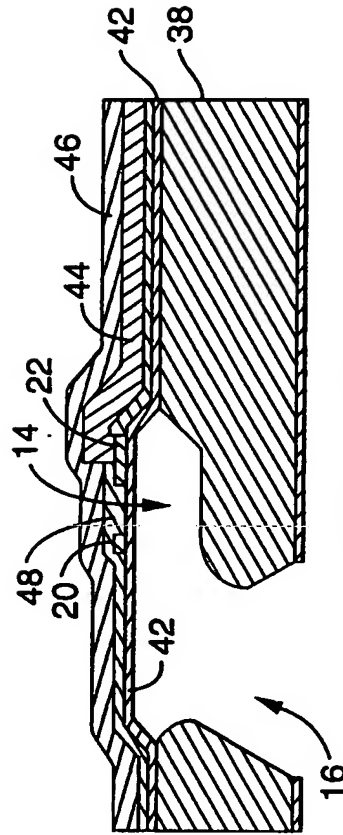


FIG. - 10

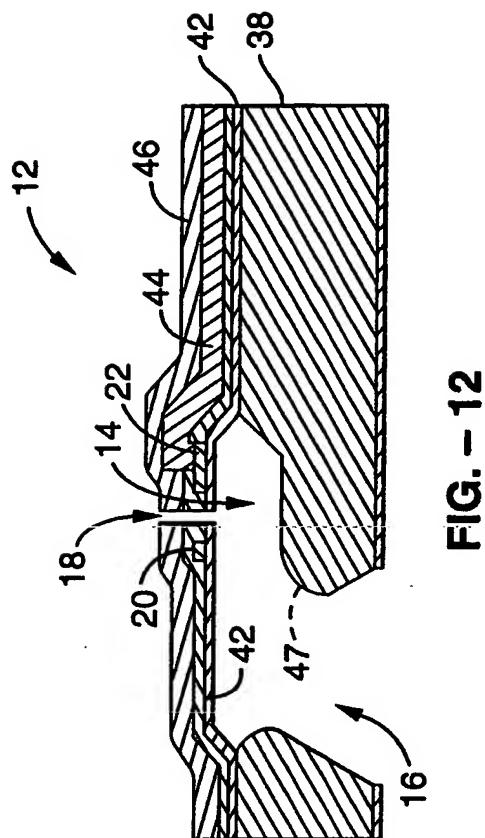


FIG. - 12

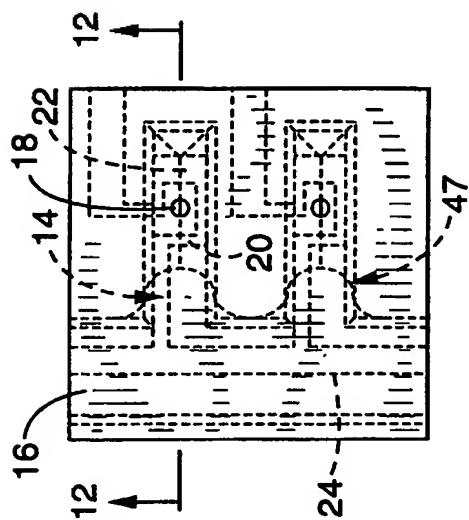


FIG. - 11

INTERNATIONAL SEARCH REPORT

International application No.
PCT/US99/01338

A. CLASSIFICATION OF SUBJECT MATTER

IPC(6) :B41J 2/05, 2/055

US CL :347/65

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

U.S. : 347/65, 48, 94, 1, 57, 58

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched
NONE

Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)
NONE

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X — Y	US 4,494,128 A (Vaught) 15 January 1985, (15/01/85) entire document.	1-3, 7-10, 14-16, 19, 22, 23, 26 ————— 4-6, 11-13, 17, 18, 20, 21, 24, 25, 27, 28

☒ Further documents are listed in the continuation of Box C. ☐ See patent family annex.

* Special categories of cited documents:	*T* later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
A document defining the general state of the art which is not considered to be of particular relevance	*X* document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
B earlier document published on or after the international filing date	*Y* document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art
L document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)	*A* document member of the same patent family
O document referring to an oral disclosure, use, exhibition or other means	
P document published prior to the international filing date but later than the priority date claimed	

Date of the actual completion of the international search

04 JUNE 1999

Date of mailing of the international search report

15 JUN 1999

Name and mailing address of the ISA/US
Commissioner of Patents and Trademarks
Box PCT
Washington, D.C. 20231

Facsimile No. (703) 305-3230-

Authorized officer

Joseph Hartary

Telephone No. (703) 308-3124

INTERNATIONAL SEARCH REPORT

International application No.

PCT/US99/01338

C (Continuation). DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X --- Y	U.S. 5,479,196 A (Inada) 26 December 1995, (26/12/95) figure 8, 16,15	1-3, 7-10, 14-16, 19, 22, 23,26 ----- 4-6, 11-13, 17, 18, 20, 21, 24, 25, 27, 28
X --- Y	EP 0 317 171 A (Leban) 24 May 1989, (24/05/89) Figures 1, 14,20	1-3, 7-10, 14- 16, 19, 22, 23, 26 ----- 4-6, 11-13, 17, 18, 20, 21, 24, 25, 27, 28
Y	JP 59-199256 A (Yokoi) 12 November 1984, (12/11/84) Figure 1, 102,103	1, 8, 15,22
Y	JP 62-169657 A (Komuro) 25 July 1987, (25/07/87) entire document.	1, 8, 15, 22
Y	JP 62-225364 A (Umehara) 03 October 1987, (03/10/87) Figures 4, 8,7	1,8,15,22
Y	Yu, Zhao-Zhi, Dual Heaters In A Thermal Ink Jet Channel, Xerox Disclosure Journal, V16, N2, March/April 1991, pages 91-92	1, 8, 15,22